L Number		Search Text	DB	Time stamp
-	5	nukanobu near kouki	USPAT;	2003/03/24 15:11
			US-PGPUB; DERWENT	
-	2	(danjo near keishi) and (enomoto near takashi) and (nukanobu near kouki)	USPAT; US-PGPUB;	2003/03/24 13:54
		,,	DERWENT	
-	8	danjo near keishi	USPAT;	2003/03/24 15:10
			US-PGPUB; DERWENT	2000/00/24 10:10
_	87	(enomoto near takashi)	USPAT;	2003/03/24 15:14
			US-PGPUB;	2003/03/24 15.14
_	19	313/495,496,309,336,310,311,553,554,555.ccls. and	DERWENT USPAT;	2002/02/24 45:40
		substrate and antistatic	US-PGPUB;	2003/03/24 15:18
	40	242/405 400 000 000 040 044 550 554 555	DERWENT	
-	12	313/495,496,309,336,310,311,553,554,555.ccls. and	USPAT;	2003/03/24 15:25
		substrate and antistatic and getter	US-PGPUB;	
_	8	313/495,496,309,336,310,311,553,554,555.ccls. and	DERWENT	0000/00/04 45 05
		substrate and antistatic and getter and irradiated	USPAT;	2003/03/24 15:35
		dubblicate and antistatic and getter and madiated	US-PGPUB; DERWENT	
-	2	313/495,496,309,336,310,311,553,554,555.ccls. and	USPAT;	2003/03/24 15:33
	İ	substrate and "sodium blocking" and getter and irradiated	US-PGPUB;	2003/03/24 13.33
			DERWENT	
-	5	313/495,496,309,336,310,311,553,554,555.ccls. and	USPAT;	2003/03/24 15:33
		substrate and "sodium blocking" and getter	US-PGPUB;	
	_		DERWENT	
-	5	313/495,496,309,336,310,311,553,554,555.ccls. and	USPAT;	2003/03/24 15:33
		substrate and "sodium blocking"	US-PGPUB;	10
_	11	212/405 406 200 226 240 244 552 554 555 551	DERWENT	
		313/495,496,309,336,310,311,553,554,555.ccls. and substrate and "insulating film" and getter and irradiated	USPAT;	2003/03/24 15:36
		substrate and insulating film and getter and irradiated	US-PGPUB;	
-	9	313/495,496,309,336,310,311,553,554,555.ccls. and	DERWENT USPAT;	2002/02/24 15:42
	-	substrate and "insulating film" and getter and irradiated and	US-PGPUB;	2003/03/24 15:43
		"metal oxide"	DERWENT	
	30	313/495,496,309,336,310,311,553,554,555.ccls. and	USPAT;	2003/03/31 13:58
		substrate and getter and irradiated and "metal oxide" and (film	US-PGPUB;	
		with (Sio?sub.2))	DERWENT	
•	78	313/495,496,497,309,336,310,311,553,554,555.ccls. and	USPAT;	2003/03/31 14:07
		substrate and getter and (film with (Sio?sub.2))	US-PGPUB;	
	48	313/495,496,497,309,336,310,311,553,554,555.ccls. and	DERWENT	
	40	substrate and "metal oxide" and getter and (film with	USPAT;	2003/03/31 14:14
		(Sio?sub.2))	US-PGPUB; DERWENT	
-	48	313/495,496,497,309,336,310,311,553,554,555.ccls. and	USPAT;	2003/03/31 14:17
	ļ	substrate and "metal oxide" and getter and (film with	US-PGPUB;	2003/03/31 14.17
		(Sio?sub.2)) and (FED or "field emission" or "electron source"	DERWENT	
		or "electron emitt\$3")		
-	7	313/495,496,497,309,336,310,311,553,554,555.ccls. and	USPAT;	2003/03/31 14:21
		substrate and "metal oxide" and getter and ("conductive	US-PGPUB;	
		particles" or "conductive powder" or "conductive particulate")	DERWENT	
		and (FED or "field emission" or "electron source" or "electron emitt\$3")		
	13	313/495,496,497,309,336,310,311,553,554,555.ccls. and	LICDAT.	2002/02/24 44:00
		substrate and getter and ("conductive particles" or "conductive	USPAT; US-PGPUB;	2003/03/31 14:29
		powder" or "conductive particulate") and (FED or "field	DERWENT	
	İ	emission" or "electron source" or "electron emitt\$3")		
	7	313/495,496,497,309,336,310,311,553,554,555.ccls. and	USPAT;	2003/03/31 14:51
	ì	substrate and getter and ("conductive particles" or "conductive	US-PGPUB;	
		powder" or "conductive particulate") and (FED or "field	DERWENT	
		emission" or "electron source" or "electron emitt\$3") and		
		(insulating or insulate) and (film with (Sio?sub.2))		,

substrate and getter and ("Conductive particulate") and ("FED or "field emission" or "electron source" or "electron emitt\$3") and ("substrate and getter and ("FED or "field emission" or "electron source" or "electron emitt\$3") and ("substrate and getter and ("substrate") and ("substrate and getter and ("conductive particulate") and ("substrate and getter and ("su		·			
1 313/495,496,497,309,326,310,311,553,554,555,cds. and substrate and getter and ("conductive particulate") and ("FED or "field emission" or "electron source" or "clectron emitts") and ((insulating or insulate) and (film with (Sio?sub.2)) with "metal oxide" and (FED or "field emission" or "electron emitts") and (insulating or insulate) and (film with (Sio?sub.2)) with "metal oxide" all 313/33 ccls. and substrate and getter and ("conductive particulate") and (FED or "field emission" or "electron source" or "electron emitts") and (insulating or insulate) and (film with (Sio?sub.2)) with "metal oxide" all 313/33 ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitts") and (insulating or insulate) and (FED or "field emission" or "electron source" or "electron emitts") and (insulating or insulate) and getter and (FED or "field emission" or "electron source" or "electron emitts") and (insulating or insulate) and getter and (FED or "field emission" or "electron source" or "electron emitts") and (insulating or insulate) with "metal oxide" 2 ("6087770") P.N. 2 ("6087770") P.N. 2 ("6259198") P.N. 2 ("6259198") P.N. 2 ("6259198") P.N. 2 ("6259198") P.N. 3 ("6259198") P.N. 3 ("6259198") P.N. 3 ("6259198") P.N. 3 ("6259198") P.N. 3 ("6259198") P.N. 4 ("6259198") P.N. 3 ("6259198") P.N. 3 ("6259198") P.N. 4 ("6259198") P.N. 5 ("6259198")	-	5	substrate and getter and ("conductive particles" or "conductive powder" or "conductive particulate") and (FED or "field emission" or "electron source" or "electron emitt\$3") and (insulating or insulate) and (film with (Sio?sub.2)) and "metal	US-PGPUB;	2003/03/31 15:02
313/\$3.ccls. and substrate and getter and ("conductive particulate") and (FED or "field emission" or "electron source" or "electron emitt\$3") and (insulating or insulate) and (film with (Sio?sub.2)) with "metal oxide" 2 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (insulating or insulate) and (film with (Sio?sub.2)) with "metal oxide" 2 313/\$1.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (film with (Sio?sub.2)) with "metal oxide" 2 313/\$1.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (insulating or insulator) with "metal oxide" 2 2 ("6259198").PN. 2 2 ("625	-	1	313/495,496,497,309,336,310,311,553,554,555.ccls. and substrate and getter and ("conductive particles" or "conductive powder" or "conductive particulate") and (FED or "field emission" or "electron source" or "electron emitt\$3") and (insulating or insulate) and (film with (Sio?sub.2)) with "metal	US-PGPUB;	2003/03/31 15:02
2 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (insulating or insulate) and (film with (Sio?sub.2)) with "metal oxide" USPAT; US-PGPUB; DERWENT with (Sio?sub.2) with "metal oxide" USPAT; US-PGPUB; DERWENT	-	1	313/\$3.ccls. and substrate and getter and ("conductive particles" or "conductive powder" or "conductive particulate") and (FED or "field emission" or "electron source" or "electron emitt\$3") and (insulating or insulate) and (film with	US-PGPUB;	2003/03/31 15:03
emission" or "electron source" or "electron emitt\$3") and (film with (Sio?sub.2) with "metal oxide" 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (insulating or insulator) with "metal oxide" 2 ("6259198").PN. 2 ("6087770").PN. 2 ("6259198").PN. 2 ("6259198").PN. 2 ("6259198").PN. 2 ("6259198").PN. 2 ("6259198").PN. 2 ("6259198").PN. 3 13/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (insulating or insulator) with "metal oxide" with (particles or particulate) and (Sio?sub.2) with "metal oxide" with (particles or particulate) and (Sio?sub.2) with "metal oxide" with (particles or particulate) and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) and (FED or "field emission" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) and (FED or "field emission" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) and substrate and getter and (FED or "field emission" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) and substrate and getter and (FED or "field emission" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) and substrate and getter and (FED or "field emission" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) and substrate and getter and (FED or "field emission" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) and substrate and getter and ("mage display" or "mage forming") and silica with "metal oxide" with (particles or particulate) and silica with "metal oxide" with (particles or particulate) and silica with "metal oxide" with (particles or particulate) and silica with "metal oxide" with (particles or particulate) and silica wit	-	2	313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (insulating or insulate) and (film with (Sio?sub.2)) with "metal	US-PGPUB;	2003/03/31 15:04
23 313/\$3 ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (insulating or insulator) with "metal oxide" 2 ("6087770").PN. 2 ("6087770").PN. 2 ("6259198").PN. 2 ("6259198").PN. 2 ("6259198").PN. 3 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (insulating or insulator) with "metal oxide" with (particles or particulate) and (particles or particulate) and (particles or particulate) and (particles or particulate) and (particles or particulate) and (Sio?sub.2) with "metal oxide" with (particles or particulate) and (FED or "field emission" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) and (FED or "field emission" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) and (FED or "field emission" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) and (FED or "field emission" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) and (FED or "field emission" or "electron source" or "electron so	-	2	emission" or "electron source" or "electron emitt\$3") and (film	US-PGPUB;	2003/04/01 15:18
2	-	23	313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and	USPAT; US-PGPUB;	2003/03/31 16:26
2 ("6087770").PN. 2 ("6259198").PN. 2 ("6259198").PN. 2 ("6259198").PN. 3 13/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (insulating or insulator) with "metal oxide" and (particles or particulate) 4 (Sio?sub.2) with "metal oxide" with (particles or particulate) 5 (Sio?sub.2) with "metal oxide" with (particles or particulate) 6 (Sio?sub.2) with "metal oxide" with (particles or particulate) 7 (Sio?sub.2) with "metal oxide" with (particles or particulate) 8 (Sio?sub.2) with "metal oxide" with (particles or particulate) 9 (Sio?sub.2) with "metal oxide" with (particles or particulate) 1 (Sio?sub.2) with "metal oxide" with (particles or particulate) 1 (Sio?sub.2) with "metal oxide" with (particles or particulate) 1 (Sio?sub.2) with "metal oxide" with (particles or particulate) 1 (Sio?sub.2) with "metal oxide" with (particles or particulate) 1 (Sio?sub.2) with "metal oxide" with (particles or particulate) 1 (Sio?sub.2) with "metal oxide" with (particles or particulate) 2 (Sio?sub.2) with "metal oxide" with (particles or particulate) 2 (Sio?sub.2) with "metal oxide" with (particles or particulate) 2 (Sio?sub.2) with "metal oxide" with (particles or particulate) 3 (Sio?sub.2) with "metal oxide" with (particles or particulate) 3 (Sio?sub.2) with "metal oxide" with (particles or particulate) 4 (Sio?sub.2) with "metal oxide" with (particles or particulate) 3 (Sio?sub.2) with "metal oxide" with (particles or particulate) 4 (Sio?sub.2) with "metal oxide" with (particles or particulate) 3 (Sio?sub.2) with "metal oxide" with (particles or particulate) 4 (Sio?sub.2) with "metal oxide" with (particles or particulate) 5 (Sio?sub.2) with "metal oxide" with (particles or particulate) 5 (Sio?sub.2) with "metal oxide" with (particles or particulate) 5 (Sio?sub.2) with "metal oxide" with (particles or particulate) 6 (Sio?sub.2) with "metal oxide" with (particles or particulate) 7 (Sio?sub.2) with "metal oxide" with (particles or particulate) 8 (Sio?sub.2) with "metal o	-	2	("6259198").PN.	USPAT; US-PGPUB;	2003/03/31 15:43
20 ("6259198").PN. 20 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (insulating or insulator) with "metal oxide" and (particles or particulate) 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (film with (Sio?sub.2)) with "metal oxide" with (particles or particulate) 1 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (film Us-PGPUB; DERWENT US-PG	-	2	("6087770").PN.	USPAT; US-PGPUB;	2003/03/31 15:43
1313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (insulating or insulator) with "metal oxide" with (particles or particulate) 1 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (film with (Sio?sub.2)) with "metal oxide" with (particles or particulate) 1 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) 3 313/\$3.ccls. and substrate and (FED or "field emission" or "electron source" or "field emission" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) 3 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) 3 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron source" or "electron source" or "electron source" or "electron emitt\$3") and silica with "metal oxide" with (particles or particulate) 3 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and silica with "metal oxide" with (particles or particulate) 3 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron emitt\$3") and silica with "metal oxide" with (particles or particulate) 3 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron emitt\$3") and silica with "metal oxide" with (particles or particulate) 3 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron emitt\$3") and silica with "metal oxide" with (particles or particulate) 4 4 substrate and getter and (FED or "field emission" or "lectron emitt\$3") and silica with "metal oxide" with (particles or particulate) 5 2003/03/31 16:48 2003/03/31 16:49 2003/03/31 16:49 2003/03/31 16:47 2003/03/31 16:49 2003/03/31 16:49	-	2	("6259198").PN.	USPAT; US-PGPUB;	2003/03/31 16:01
emission" or "electron source" or "electron emitt\$3") and (film with (Sio?sub.2)) with "metal oxide" with (particles or particulate) 1 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) 313/\$3.ccls. and substrate and (FED or "field emission" or "electron source" or "electron source" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) 39 39 39 39 39 30 31/\$3.ccls. and substrate and getter and (Sio?sub.2) with "metal oxide" with (particles or particulate) 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron emitt\$3") and silica with "metal oxide" with (particles or particulate) 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron emitt\$3") and silica with "metal oxide" with (particles or particulate) 313/\$3.ccls. and substrate and getter and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 4 substrate and getter and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 133 substrate and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 133 substrate and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 134 135 136 137 137 137 137 137 137 137	-	20	emission" or "electron source" or "electron emitt\$3") and (insulating or insulator) with "metal oxide" and (particles or	USPAT; US-PGPUB;	2003/03/31 16:09
emission" or "electron source" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) 313/\$3.ccls. and substrate and (FED or "field emission" or "electron source" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) 39 39 30 313/\$3.ccls. and (Sio?sub.2) with "metal oxide" with (particles or particulate) 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron emitt\$3") and silica with "metal oxide" with (particles or particulate) 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron emitt\$3") and silica with "metal oxide" with (particles or particulate) 313/\$3.ccls. and substrate and getter and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 4 4 5 5 6 7 7 8 8 8 9 8 9 9 9 9 9 9 9 9 9 9 9 9 9	-	0	emission" or "electron source" or "electron emitt\$3") and (film with (Sio?sub.2)) with "metal oxide" with (particles or	US-PGPUB;	2003/03/31 16:29
1 313/\$3.ccls. and substrate and (FED or "field emission" or "electron source" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) 39	-	1	emission" or "electron source" or "electron emitt\$3") and	US-PGPUB;	2003/03/31 16:28
substrate and (FED or "field emission" or "electron source" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or particulate) 3 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and silica with "metal oxide" with (particles or particulate) 3 313/\$3.ccls. and substrate and getter and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 4 3 3 3 3.ccls. and substrate and getter and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 4 4 5 5 6 7 7 8 9 8 9 9 9 9 9 9 9 9 9 9 9 9 9 9 9	-	1	313/\$3.ccls. and substrate and (FED or "field emission" or "electron source" or "electron emitt\$3") and (Sio?sub.2) with	USPAT; US-PGPUB;	2003/03/31 16:28
3 313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and silica with "metal oxide" with (particles or particulate) 3 313/\$3.ccls. and substrate and getter and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 4 3 3 313/\$3.ccls. and substrate and getter and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 4 3 3 3 3 3 3 3 3 3 3 3 3 3 3 3 3 3 3 3	-	39	substrate and (FED or "field emission" or "electron source" or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with	USPAT; US-PGPUB;	2003/04/01 09:57
3 313/\$3.ccls. and substrate and getter and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 4 substrate and getter and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 133 substrate and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 134 substrate and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 135 substrate and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 136 substrate and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 137 substrate and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 138 substrate and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 139 substrate and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 140 substrate and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 150 substrate and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate)	-	3	313/\$3.ccls. and substrate and getter and (FED or "field emission" or "electron source" or "electron emitt\$3") and silica	USPAT; US-PGPUB;	2003/03/31 16:46
substrate and getter and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 133 substrate and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate) 2003/03/31 16:47 USPAT;	-	3	313/\$3.ccls. and substrate and getter and ("image display" or "image forming") and silica with "metal oxide" with (particles or	USPAT; US-PGPUB;	2003/04/01 09:55
substrate and ("image display" or "image forming") and silica USPAT; US-PGPUB; 2003/03/31 16:48	-	4	substrate and getter and ("image display" or "image forming")	USPAT; US-PGPUB;	2003/03/31 16:47
	~	133	substrate and ("image display" or "image forming") and silica with "metal oxide" with (particles or particulate)	USPAT; US-PGPUB;	2003/03/31 16:48

	41	substrate and /"image display" or "image forming"	LIODAT	T 00001001001
	7'	substrate and ("image display" or "image forming") and	USPAT;	2003/03/31 16:48
		(sio?sub.2) with "metal oxide" with (particles or particulate)	US-PGPUB;	
		242/62 cala and a high state of the state of	DERWENT	
•	6	313/\$3.ccls. and substrate and ("image display" or "image	USPAT;	2003/04/01 09:55
		forming") and (silica or (sio?sub.2)) with "metal oxide" with	US-PGPUB;	
		(particles or particulate)	DERWENT	
-	1	313/\$3.ccls. and (FED or "field emission" or "electron source"	USPAT:	2003/04/01 09:59
	-	or "electron emitt\$3") and (Sio?sub.2) with "metal oxide" with	US-PGPUB;	
		(particles or particulate)	DERWENT	
	105	(== at the attribution of clock of a clock of	USPAT:	2003/04/01 11:16
		emitt\$3") and (Sio?sub.2) with "metal oxide" with (particles or	US-PGPUB;	
		particulate)	DERWENT	
-	1	("0037183").PN.	USPAT;	2003/04/01 12:29
			US-PGPUB;	2000/01/01 12:20
			DERWENT	
-	2	("6184610").PN.	USPAT:	2003/04/01 13:21
			US-PGPUB;	2000/04/01 10.21
			DERWENT	
-	0	313/\$3.ccls. and substrate and getter with "electron source"	USPAT;	2003/04/01 15:18
		and (FED or "field emission" or "electron source" or "electron	US-PGPUB;	2003/04/01 13.16
		emitt\$3")	DERWENT	
-	19		USPAT;	2002/04/04 45:00
		or "electron emitt\$3") and substrate and getter with "electron		2003/04/01 15:20
		source"	US-PGPUB; DERWENT	
			DEKAMENI	ļ